IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Date	July 11 2008	

In re the Application of

Takatomo YAMAGUCHI et al.

Group Art Unit: 1792

Application No.: 10/574,568

Examiner:

K. CHEN

Filed: August 7, 2006

Docket No.: 127569

For:

SUBSTRATE PROCESSING APPARATUS, SUBSTRATE HOLDER, AND

MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE

LARGE ENTITY PETITION FOR 1st - 3rd EXTENSION OF TIME UNDER 37 C.F.R. §1.136(a) AND TRANSMITTAL OF FEE UNDER 37 C.F.R. §1.17

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Transi	mitted herewith is a response to the outstanding Official Action in the above-identified patent
application. Th	ne shortened statutory period having expired April 16, 2008, an extension of time for a period of
three month is	hereby requested. Attached hereto is our Check No. 207534 in the amount of \$1050.00 in
payment for:	
1	Extension fee for response within first month pursuant to §1.136(a) (\$120.00)
]	Extension fee for response within second month pursuant to §1.136(a) (\$460.00)
<u>X</u> 1	Extension fee for response within third or subsequent month pursuant to §1.136(a) (\$1050.00)

The Commissioner is hereby authorized to charge any additional fee or credit any overpayment associated with this communication to Deposit Account No. 15-0461.

Respectfully submitted,

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DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461